



FEB 19 2008

JFW

UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 8857  
Akira KABESHITA et al. : Attorney Docket No. 2005\_1927A  
Serial No. 10/564,275 : Group Art Unit 3729  
Filed January 11, 2006 : Examiner Tai V. Nguyen

COMPONENT MOUNTING APPARATUS  
AND COMPONENT MOUNTING METHOD

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

In response to the Restriction Requirement of January 24, 2008, Applicants hereby elect **Group II**, which is drawn to a component mounting method for mounting a plurality of components by moving the wafer holding table from the first component feeding position to the second component feeding position, holding and taking out the component by the second mounting head at the second component feeding position, and then returning the wafer holding table to the first component feeding position to be located there and is embodied by claims 10-13.

Applicant's note that claim 13 which was omitted in the Restriction Requirement dated January 24, 2008, should be included in Group II.

Having made the required election, a full examination on the merits of the elected group is requested.

Respectfully submitted,

Akira KABESHITA et al.

By: 

Michael S. Huppert  
Registration No. 40,268  
Attorney for Applicants

MSH/kjf  
Washington, D.C. 20006-1021  
Telephone (202) 721-8200  
Facsimile (202) 721-8250  
February 19, 2008